

**In the Claims**

Claims 1-25 were previously cancelled without prejudice.

Non-elected claims 33, 35, 37-39, 44-48, 51 and 52 have been withdrawn without prejudice.

Please cancel claim 49 without prejudice.

Please amend claims 26, 27, 28, 29, 30, 31, 32, 34, 36, 40, 41, 42, 43, and 50 as indicated in the attached Claims Listing.

Please add new claims 53 and 54 as set forth in the attached Claims Listing

A complete Claims Listing showing all claims presently in the application and indicating the present status of each pending claim, is attached as required by 37 C.F.R. § 1.121(c).

Claims 1-25 (Cancelled).

26. (Currently Amended) [Optical] An optical imaging device, in particular an objective for carrying out semiconductor microlithography [in the field of EUVL] at an extreme ultra-violet wavelength [for producing semiconductor elements, having a beam path], said device comprising:

a plurality of optical elements disposed in a beam path for a beam of extreme ultra-violet light;

a plurality of diaphragms each of which has a respective diaphragm opening of a fixed geometry, said fixed geometry of said diaphragm openings being different in different respective ones of said diaphragms and,

a diaphragm device for storing said diaphragms in a diaphragm store and selectively exchanging diaphragms between said diaphragm store and an operating position, said diaphragm openings of said diaphragms present in said diaphragm store being located out of the beam path, the said diaphragm opening of a said diaphragm present in said operating position being located in the beam path, whereby the objective can be selectively stopped down according to the said fixed geometry of the said diaphragm opening of any one of said diaphragms from said diaphragm store which is selectively introduced into said operating position [with an adjustable diaphragm opening shape, wherein the diaphragm device has a diaphragm store with a plurality of different diaphragm openings with fixed shapes in each case, which can be introduced into the beam path].

27. (Currently Amended) [Optical] An optical imaging device according to [[Claim]] claim 26, wherein said diaphragm store [is designed as] comprises a revolving disc diaphragm stack and said plurality of diaphragms comprises [with] a plurality of individual revolving disc diaphragms which are provided with said diaphragm openings.

28. (Currently Amended) [Optical] An optical imaging device according to [[Claim]] claim 27, wherein said optical imaging device further comprises a housing within which

said optical elements are located and, [wherein] said revolving disc diaphragm stack is  
[arranged] located outside of said housing [optical imaging device].

29. (Currently Amended) [Optical] An optical imaging device according to [[Claim]]  
claim 27, wherein said diaphragm store further comprises a plurality of separate plug-in  
units and individual ones of said revolving disc diaphragms are [accommodated inside]  
stored in said revolving disc diaphragm stack in respective individual ones of said  
separate plug-in units.

30. (Currently Amended ) [Optical] An optical imaging device according to [Claims]  
claim 27, wherein said housing includes an opening through which said diaphragms are  
exchanged between said diaphragm store and said operating position [and] said revolving  
disc diaphragm stack is [designed displaceably in such a way that said revolving disc  
diaphragm to be] displaceable relative to said opening in said housing for positioning any  
selected one of said revolving disc diaphragms for introduction [introduced] into said  
operating position by way of said opening [the beam path can be selected by displacing  
said revolving disc diaphragm stack].

31. (Currently Amended) [Optical] An optical imaging device according to [Claim  
27] claim 29, wherein said diaphragm device [has] further comprises a feeder device  
which removes a said revolving disc diaphragm [to be introduced into the beam path]  
from a said separate plug-in unit of said revolving disc diaphragm stack, [in particular  
also from the corresponding separate plug-in unit,] introduces [it] said revolving disc  
diaphragm into the beam path, and [deposits it again] re-deposits said revolving disc  
diaphragm in said revolving disc diaphragm stack after [it] said revolving disc diaphragm  
has been used in said operating position.

32. (Currently Amended) [Optical] An optical imaging device according to [[Claim]]  
claim 31, wherein said feeder device [is designed as] comprises a moveable robot gripper  
arm.

33. (Withdrawn) Optical imaging device according to Claim 27, wherein said diaphragm device has a lifting device for positioning said revolving disc diaphragm in the beam path.

34. (Currently Amended) [Optical] An optical imaging device according to [[Claim]] claim 27, wherein said diaphragm device has a holding device for fixing said revolving disc diaphragm in the beam path.

35. (Withdrawn) Optical imaging device according to Claim 27, wherein one of said optical elements has a holding device for fixing said revolving disc diaphragm in the beam path.

36. (Currently Amended ) [Optical] An optical imaging device according to [[Claim]] claim 27, wherein said diaphragm device has a lifting device [[has]] which is provided with, a holding device for fixing said revolving disc diaphragm in the beam path.

37. (Withdrawn) Optical imaging device according to Claim 34, wherein said lifting device is pressed against said holding device by spring elements for the purpose of dynamically decoupling said revolving disc diaphragm from said optical imaging device.

38. (Withdrawn) Optical imaging device according to Claim 34, wherein for the purpose of dynamically decoupling said revolving disc diaphragm from said optical imaging device, said revolving disc diaphragm can be fixed on said holding device via magnetic forces.

39. (Withdrawn) Optical imaging device according to Claim 33, wherein said lifting device is dynamically decoupled.

40. (Currently Amended) [Optical] An optical imaging device according to [[Claim]] claim 27, further comprising a housing within which said optical elements are

located, said housing having an opening through which said revolving disc [diaphragm can be] diaphragms are introduced into the beam path.

41. (Currently Amended) [Optical] An optical imaging device according to [[Claim]] claim 26, wherein said diaphragm device is dynamically decoupled.

42. (Currently Amended) [Optical] An optical imaging device according to [Claim 33] claim 32, wherein said diaphragm device has a lifting device for positioning said revolving disc diaphragm in the beam path and wherein said lifting device picks up said revolving disc diaphragm from said robot gripper arm.

43. (Currently Amended) [Optical] An optical imaging device according to [Claim 33] claim 32, wherein said lifting device [is designed as a rocker] moves said revolving disc diaphragm according to a rocking steering movement.

44. (Withdrawn) Optical imaging device according to Claim 33, wherein said lifting device is designed as a set of scales, in particular with a parallelogram guide.

45. (Withdrawn) Optical imaging device according to Claim 33, wherein said lifting device is of pantographic design, in particular having solid joints.

46. (Withdrawn) Optical imaging device according to Claim 26, wherein a sheet-metal strip which is wound onto two rollers and held tensioned is provided as a diaphragm store, said sheet-metal strip having a plurality of, in particular, various diaphragm openings of fixed shapes, and it being possible by rotating said rollers to adjust said diaphragm setting by varying the diaphragm openings.

47. (Withdrawn) Optical imaging device according to Claim 46, wherein the tension of said sheet-metal strip, and the height of said diaphragm opening, are kept constant by at least two additional guide rollers, which cause a resilient pretensioning, the first roller being arranged in a fixed fashion, and the second being supported flexibly in the spacing direction.

48. (Withdrawn) Optical imaging device according to Claim 46, wherein the position of said diaphragm openings can be determined by markings, in particular by cut-outs, at the edge of said sheet-metal strip.

49. (Canceled).

50. (Currently Amended) [Diaphragm] A diaphragm device for stopping down [an optical imaging device, in particular an objective for microlithography in the field of EUVL] an objective of the type used for carrying out semiconductor microlithography with a beam of extreme ultra-violet light directed along a beam path [for producing semiconductor components in accordance with claim 26], said diaphragm device comprising:

a plurality of diaphragms each of which has a respective diaphragm opening of a fixed geometry, said fixed geometry of said diaphragm openings being different in different respective ones of said diaphragms;

a diaphragm store for storing said diaphragms such that said diaphragm openings of said diaphragms present in said diaphragm store are not in the beam path, and a diaphragm exchange mechanism for selectively exchanging said diaphragms between said diaphragm store and an operating position in the objective, said operating position being a position wherein the said diaphragm opening of a said diaphragm present in said operating position is located in the beam path, whereby the objective can be selectively stopped down according to the said fixed geometry of the said diaphragm opening of whichever one of said diaphragms from said diaphragm store is selectively introduced into said operating position .

51. (Withdrawn) EUV projection exposure machine comprising at least one mirror and a diaphragm device with an adjustable diaphragm opening shape which is located nearby said mirror, wherein at least three, in particular at least six different diaphragm opening shapes can be implemented.

52. (Withdrawn) EUV projection system according to claim 51, wherein said

diaphragm opening is arranged in said diaphragm in a decentral manner.

53. (New) A diaphragm device for stopping down an objective of the type used for carrying out semiconductor microlithography with a beam of extreme ultra-violet light directed along a beam path, said diaphragm device comprising:

- a plurality of optical elements;

- a diaphragm device with an adjustable diaphragm opening shape, wherein the diaphragm device has a diaphragm store which comprises a revolving disc diaphragm stack with a plurality of individual revolving disc diaphragms which are provided with different diaphragm openings with fixed shapes in each case, which can be introduced into the beam path, and

- a lifting device for positioning said revolving disc diaphragms in the beam path.

54. (New) A diaphragm device for stopping down an objective of the type used for carrying out semiconductor microlithography with a beam of extreme ultra-violet light directed along a beam path, said diaphragm device comprising:

- a plurality of optical elements and a diaphragm device with an adjustable diaphragm opening shape, wherein the diaphragm device has a diaphragm store with a plurality of different diaphragm openings with fixed shapes in each case, which can be introduced into the beam path.